## **Amendments to the Claims:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

## **Listing of Claims:**

- 1-16. (canceled)
- 17. (previously presented) A shielded cable comprising:
  a cable body comprising electrical conductors disposed within an insulating substrate;
- a vacuum metallized shielding layer disposed over the insulating substrate;
  a metallized thermoform connector coupled to an end portion of the cable body
  and electrically coupled to the vacuum metallized layer, wherein the connector can be
  electrically coupled to a grounded housing so as to ground the shielding layer and connector; and
  wherein the connector further comprises spaced protrusions, wherein the
  connector is electrically coupled to the metallized layer with the spaced protrusions, and
  wherein the spaced protrusions have a height and spacing between an adjacent
  protrusion that is no larger than one-half a wavelength of a released radiation.

18-40. (canceled)

- 41. (previously presented) The cable of claim 17 further comprising an insulating top coating disposed over the vacuum metallized layer to insulate the vacuum metallized layer.
- 42. (previously presented) The cable of claim 41 wherein the insulating top layer extends to a point short of the connector such that the connector is electrically coupled to the metallized layer.
- 43. (previously presented) The cable of claim 17 wherein the vacuum metallized layer has a thickness between approximately one-half micron to twelve microns.

**PATENT** 

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44. (previously presented) The cable of claim 17 wherein the metallized thermoform is coupled to an outsize surface of a nonconductive connector.